



PATENT

Atty. Dkt. No. AMAT/5765/CMP/CMP/RKK

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Li, et al.

Serial No.: 10/026,854

Confirmation No.: 1816

Filed: December 20, 2001

For: Articles for Polishing  
Semiconductor Substrates

Group Art Unit: 1765

Examiner: Lan Vinh

MAIL STOP  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on January 8, 2004, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
Date 1/8/04	Signature <i>Keith R. [unclear]</i>

Dear Sir:

**RESPONSE TO OFFICE ACTION DATED NOVEMBER 10, 2003**

In response to the Office Action dated November 10, 2003, having a shortened statutory period for response extended one-month to expire on January 10, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5765/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**The Pending Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 8 of this paper.